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Substitute for form 149A/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>		Application Number	10/631,825
		Filing Date	August 1, 2003
		First Named Inventor	LACOURSE, Alain
		Art Unit	3765
		Examiner Name	
Sheet 1	of 1	Attorney Docket Number	06042-006-US-02

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Pages, Columns, Line, Where Relevant Passages or Relevant Figures Appear
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SP	D	EP 0 472 331	02-26-92			
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS). Title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number (s), publisher, city and/or country where published.	T
SP		Parker D L et al: "Polysilicon Resistor trimming by laser link making" IEEE Transactions on semiconductor manufacturing, IEEE inc. New York, US, vol 3, no. 2, 1 may 1990 pages 80-83,	

Examiner Signature	Evan R +	Date Considered	12/27/04
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